

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Shunpei Yamazaki et al Art Unit : 2825
Serial No. : 09/894,950 Examiner : Caridad Everhart
Filed : June 27, 2001 Confirmation No.: 6263
Title : SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

MAIL STOP RCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Applicants request consideration of the references listed on the attached PTO-1449 form. Under 37 C.F.R. § 1.98 (a)(2)(ii), only copies of foreign patent documents and/or non-patent literature are enclosed. A copy of the listed U.S. patent can be provided upon request.

Submitted herewith is an English translation of the following foreign language references, or portions thereof:

Desig. ID	Source
AL	JAPAN 11-087726 – English Abstract: DIALOG(R)File 347:JAPIO (2005); Accession No. 06146186
AM	JAPAN 10-031235 – English Abstract: DIALOG(R)File 347:JAPIO (2005); Accession No. 05748135 and family to U.S. Patent No. 5,966,193 (Desig. ID “AA”)

The Japanese Patent Office is contending that paragraph [0054] of Japan 11-087726 is of particular relevance. An English language translation is being prepared, and will be submitted for consideration in a supplemental information disclosure statement.

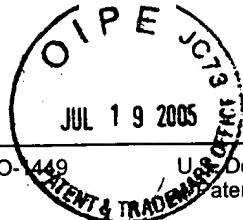
This filing is being made with the filing of a Request for Continued Examination. No fee is required.

Respectfully submitted,

John F. Hayden
Reg. No. 37,640

Date: July 19, 2005

Customer No. 26171
Fish & Richardson P.C.
1425 K Street, N.W., 11th Floor
Washington, DC 20005-3500
Telephone: (202) 783-5070
Facsimile: (202) 783-2331



Substitute Form PTO-1449 (Modified) Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b))	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 07977-280001	Application No. 09/894,950
	Applicant Shunpei Yamazaki et al		
	Filing Date June 27, 2001	Group Art Unit 2825	

U.S. Patent Documents

Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	5,966,193	10/12/1999	Zhang et al.			07/11/1997
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents or Published Foreign Patent Applications

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AL	11-087726	03/30/1999	JAPAN			AB	
	AM	10-031235	02/03/1998	JAPAN			AB	
	AN							
	AO							
	AP							

Other Documents (include Author, Title, Date, and Place of Publication)

Examiner Initial	Desig. ID	Document
	AQ	
	AR	
	AS	
	AT	

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	